

<b>Notice of References Cited</b>	Application/Control No. 10/755,719	Applicant(s)/Patent Under Reexamination HAVENER, JOHN P.	
	Examiner Zoila E. Cabrera	Art Unit 2125	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,720,003	02-1998	Chiang et al.	706/21
	B	US-5,842,189	11-1998	Keeler et al.	706/16
	C	US-6,002,839	12-1999	Keeler et al.	706/23
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
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**NON-PATENT DOCUMENTS**

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